



**RESPONSE UNDER 37 CFR 1.116  
- EXPEDITED PROCEDURE -  
EXAMINING GROUP ART UNIT 1743**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*OKAY to enter  
7/12/04*  
APPLICANTS: Zhijian Lu et al.

EXAMINER: A. Soderquist

SERIAL NO.: 09/966,923

GROUP: Art Unit 1743

FILED: September 28, 2001

DOCKET: 01P14628US (8055-108)

FOR: Method For Ending Point Detection During Etching Process

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313  
Mail Stop-AF

**RESPONSE**

This is a response to the Final Office Action mailed on May 10, 2004. Applicants respectfully request reconsideration of the claim rejections.

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the: Commissioner for Patents, P.O. Box 1450, Alexandria, VA. 22313, on July 12, 2004.

Dated: 7/12/04

  
Frank DeRosa